

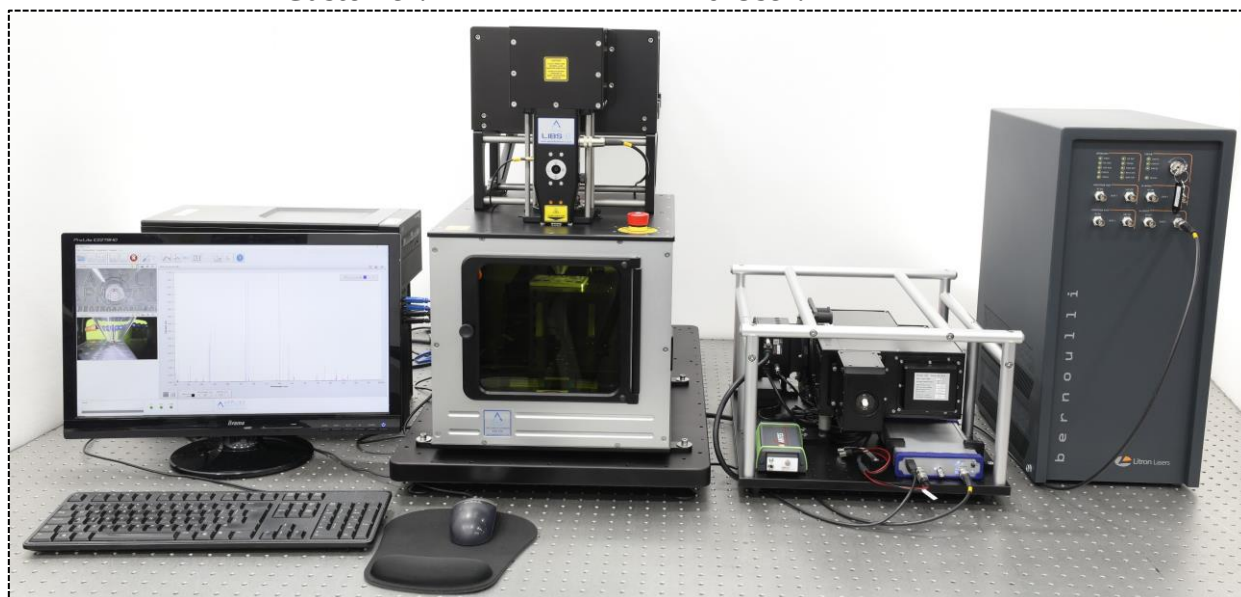


Modular LIBS System Test Report Example Configuration 2

June 2022

Customer: XXXXXXXX

End User: XXXXXXXX



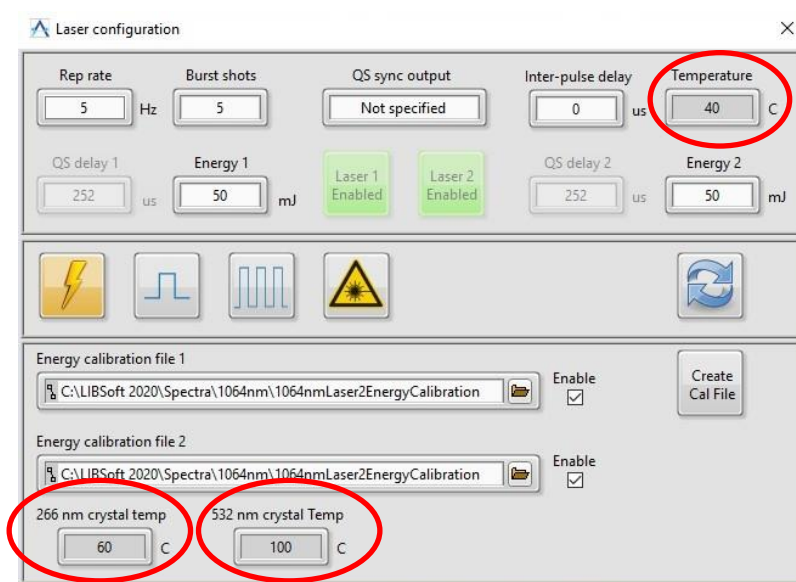
System Information	Laser Information
LIBS-6 (6-channel, 266 nm) Serial No: XXXX, Manufactured: June 2020 LIBS-6 (6-channel, 1064 nm) Serial No: XXXX, Manufactured: June 2020 AP-B-266 Serial No: XXXX, Manufactured: June 2020 AP-B-1064 Serial No: XXXX, Manufactured: June 2020	Litron Bernoulli G 200-20 Laser head Serial No: XXXX LPU550B Serial No: XXXX LUCI Serial No: XXXX
Sample Chamber Information	Spectrometer Information
XYZ-750 Serial No: XXXX Manufactured: June 2020	- Echelle Spectrograph, Model: EMU-120/65 UV-VIS-NIR, Serial No: XXXX (Catalina Scientific Instruments LLC) - EMCCD Camera, Model: Falcon 285, Model Number: FA285B-CL-OEM2, Serial No: XXXX (Raptor Photonics Ltd) - Digital delay pulse generator, Model: Sapphire Plus, Model number: 9212+, Serial No: XXXX (Quantum Composers Inc)
Software	Fibre Information
LIBSoft 2020	1 off FC-UV400-2-ME-SR Length 2 m 1 off FC-UV400-0.5-ME-SR Length 0.5m
Optional Extras	
IMG-HR High-resolution camera imaging kit (x3)	AvaLight-CAL-Mini Mercury Argon Calibration lamp Serial No: XXXX
SpecLine AM Software V 2.1 Serial No: XXXX	Coherent LabMax TOP, Serial No: XXXX EnergyMax sensor, J50MB-YAG, Serial No: XXXX

Laser Energy Calibration

The laser beam energy was measured using a calibrated laser energy meter (Coherent LabMax TOP Laser Power/Energy meter with J-50MB-YAG detector head). The laser pulse energy was measured at the output of the LIBS-6, with the transparent nozzle aperture removed and the detector head positioned close to the optics array so that the laser beam diameter is relatively large (so as not to damage the detector). The energy measurements are therefore representative of the laser pulse energy at the sample. The laser energy calibration was performed by varying the Flashlamp-Q-Switch (FL-QS) delay (FL-QS Delay values: 125 μ s - 340 μ s) and measuring the average, minimum and maximum energy as well as standard deviation of 50 shots. The repetition rate was set to 5 Hz. Prior to the measurements and for laser warm up/stabilization purposes, the flashlamp was operating without lasing (i.e. Q-Switch off) for 10 min. The laser coolant temperature during the laser energy calibration measurements ranged from 40 to 42 °C. **For optimum laser performance, the coolant temperature should reach a minimum of 30°C when the laser is configured for 1064 nm. This is achieved by firing the flashlamp with the Q-Switch disabled until this temperature is reached. If the laser is configured for 266 nm, the coolant temperature should be allowed to reach a minimum of 40°C for optimum performance.**

For both configurations 266 nm and 1064 nm, the harmonic generator crystal temperatures inside the laser head should reach their optimum values, 100°C for the 532 nm crystal and 60°C for the 266 nm crystal.

The temperature readings of the laser coolant and the crystals are reported in LIBSoft in the laser configuration window.



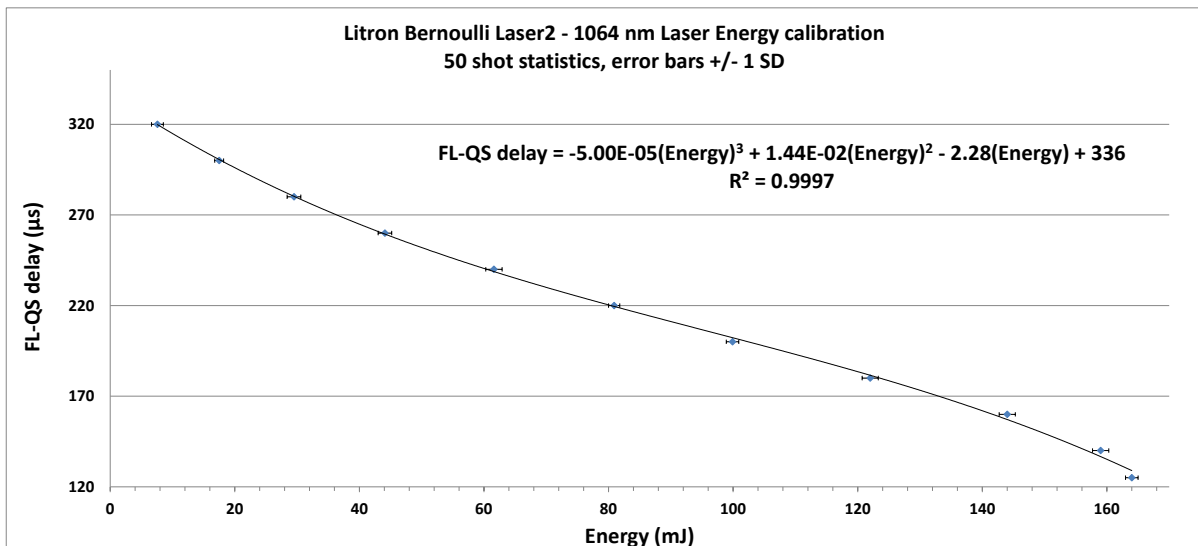
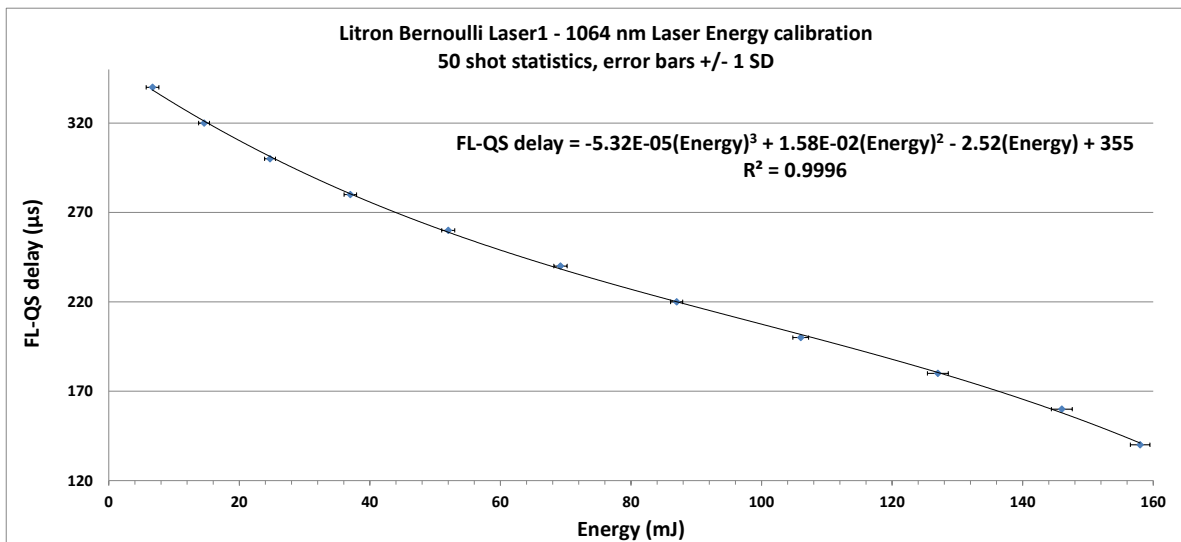
The screenshot shows the 'Laser configuration' window with the following settings:

- Rep rate:** 5 Hz
- Burst shots:** 5
- QS sync output:** Not specified
- Inter-pulse delay:** 0 μ s
- Temperature:** 40 °C (highlighted with a red circle)
- QS delay 1:** 252 μ s
- Energy 1:** 50 mJ
- Laser 1:** Enabled
- Laser 2:** Enabled
- QS delay 2:** 252 μ s
- Energy 2:** 50 mJ
- Energy calibration file 1:** C:\LIBSoft 2020\Spectra\1064nm\1064nmLaser2EnergyCalibration (Enabled)
- Energy calibration file 2:** C:\LIBSoft 2020\Spectra\1064nm\1064nmLaser2EnergyCalibration (Enabled)
- 266 nm crystal temp:** 60 °C (highlighted with a red circle)
- 532 nm crystal Temp:** 100 °C (highlighted with a red circle)

1064 nm configuration

Important. Attach the laser head to the 1064 nm adaptor platform, the 1064 nm mirror module and the 1064 nm LIBS-6 module (each item is labelled accordingly). Please refer to the User's Manual for further guidance on configuring the hardware. Note that using the laser in the 1064 nm configuration with the 266 nm mirror module and/or the 266 nm LIBS-6 module will lead to damage of the optics and possibly also the laser head.

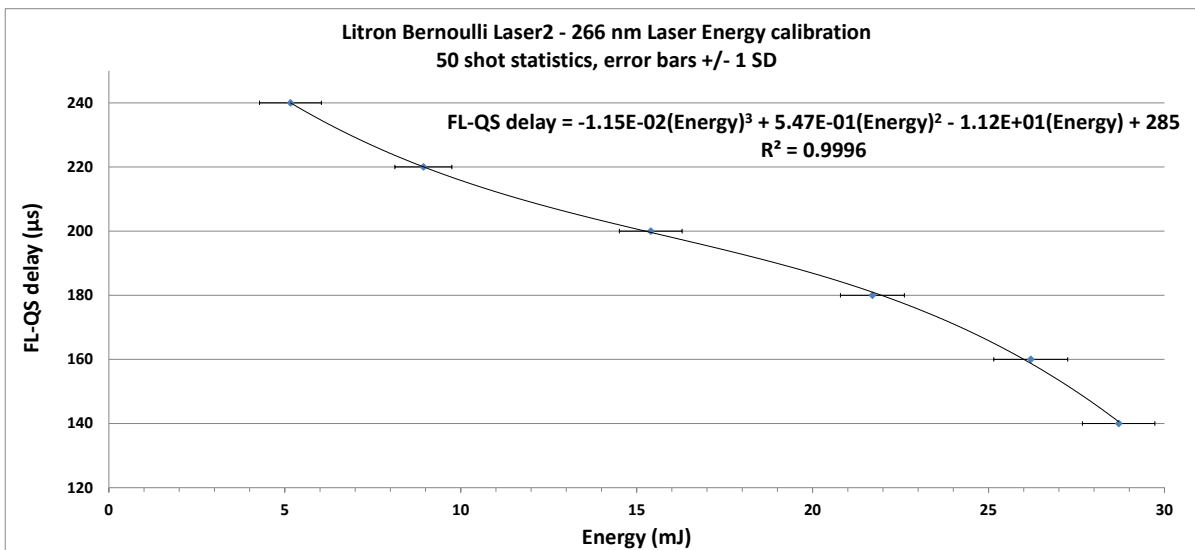
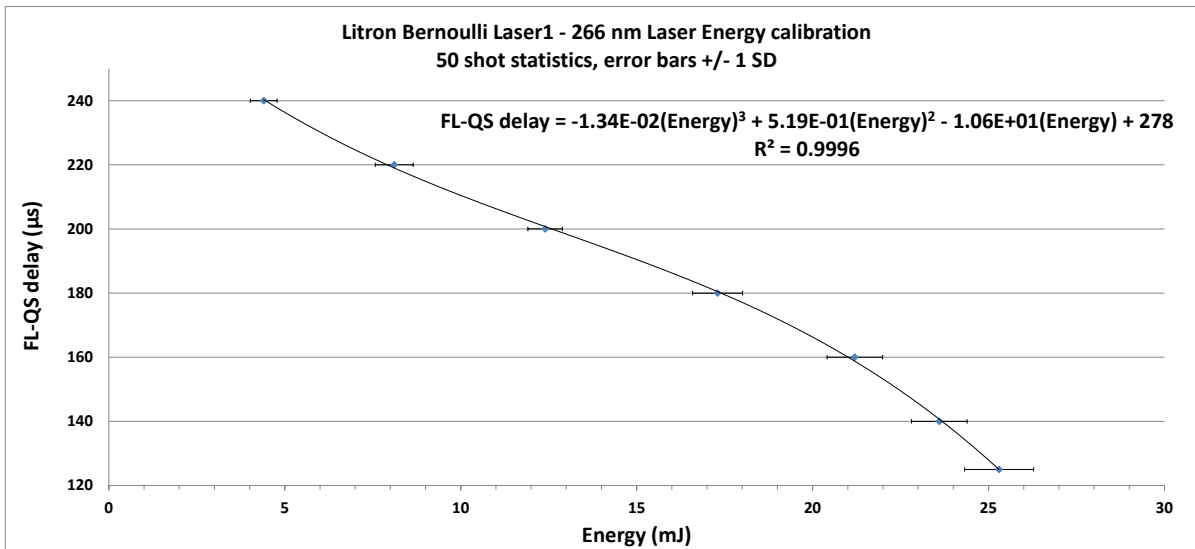
FL-QS Delay (μs)	Laser 1 Energy					Laser 2 Energy				
	Mean (mJ)	SD (mJ)	RSD (%)	Min. (mJ)	Max. (mJ)	Mean (mJ)	SD (mJ)	RSD (%)	Min. (mJ)	Max. (mJ)
125	159	1.3	0.8	157	162	164	1.0	0.6	161	166
140	158	1.5	0.9	155	162	159	1.3	0.8	155	162
160	146	1.6	1.1	141	149	144	1.3	0.9	141	147
180	127	1.6	1.3	122	129	122	1.3	1.1	120	126
200	106	1.2	1.1	104	109	99.9	1.0	1.0	97.6	100
220	87.0	0.93	1.1	84.7	88.8	80.9	0.91	1.1	78.7	83.0
240	69.2	1.0	1.4	66.9	71.2	61.6	1.3	2.1	57.2	64.3
260	52.0	1.0	1.9	49.6	54.1	44.1	1.1	2.5	41.8	46.7
280	37.0	0.96	2.6	34.8	39.2	29.5	1.1	3.7	26.4	31.8
300	24.7	0.83	3.4	22.8	26.0	17.5	0.71	4.1	15.5	18.9
320	14.6	0.83	5.7	12.7	16.8	7.58	0.95	12	5.16	9.35
340	6.71	0.98	15	3.63	6.98	--	--	--	--	--



266 nm configuration

Important. Attach the laser to the 266 nm adaptor platform, the 266 nm mirror module and the 266 nm LIBS-6 module (each item is labelled accordingly). Please refer to the User's Manual for further guidance on configuring the hardware. Note that using the laser in the 266 nm configuration with the 1064 nm mirror module and/or the 1064 nm LIBS-6 module will lead to damage of the optics and possibly also the laser head.

FL-QS Delay (μs)	Laser 1 Energy					Laser 2 Energy				
	Mean (mJ)	SD (mJ)	RSD (%)	Min. (mJ)	Max. (mJ)	Mean (mJ)	SD (mJ)	RSD (%)	Min. (mJ)	Max. (mJ)
125	25.3	0.98	3.9	22.1	27.4	28.7	1.03	3.6	26.0	30.6
140	23.6	0.79	3.3	21.8	25.3	28.7	1.05	3.7	25.7	30.9
160	21.2	0.79	3.7	19.9	23.1	26.2	0.91	3.5	24.0	28.4
180	17.3	0.71	4.1	15.8	19.1	21.7	0.89	4.1	18.8	23.7
200	12.4	0.49	4.0	11.7	13.5	15.4	0.81	5.3	13.3	17.2
220	8.11	0.54	6.7	6.99	9.14	8.94	0.88	9.8	7.33	10.8
240	4.40	0.38	8.6	3.61	5.39	5.16	0.58	11	4.05	6.21

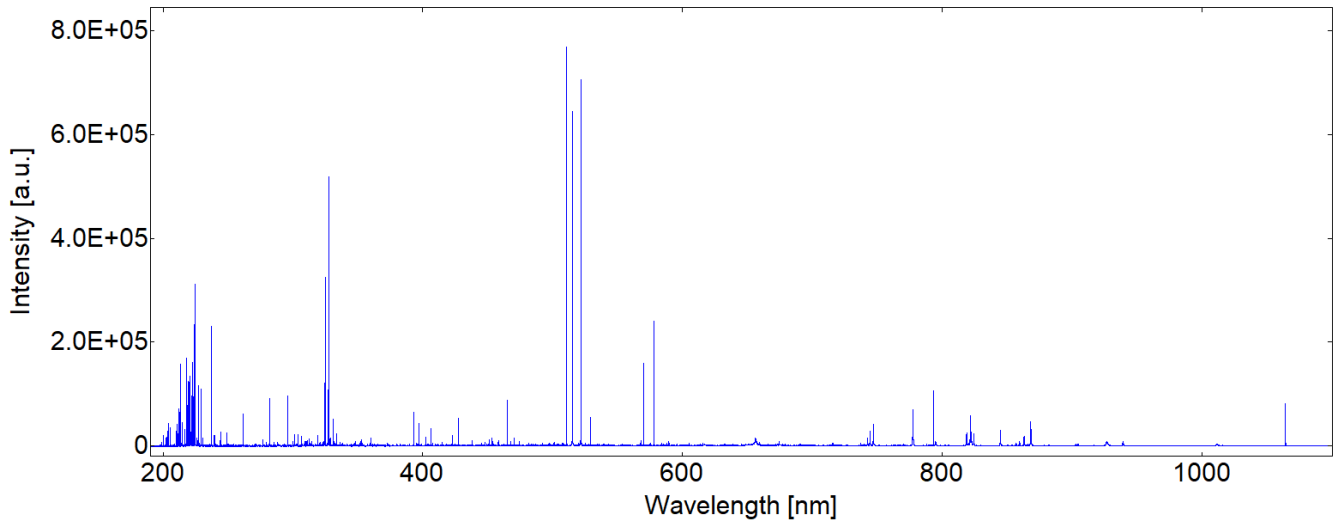


Test spectra 1064 nm configuration (UV3 Echelle dispersion cassette)

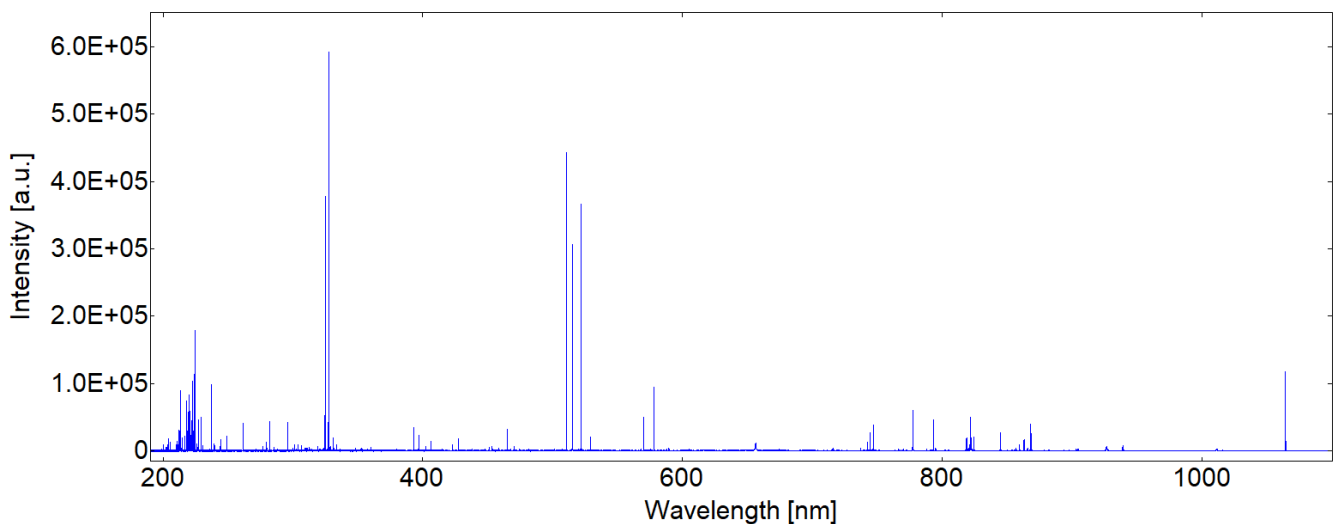
The spectra were acquired using the following parameters:

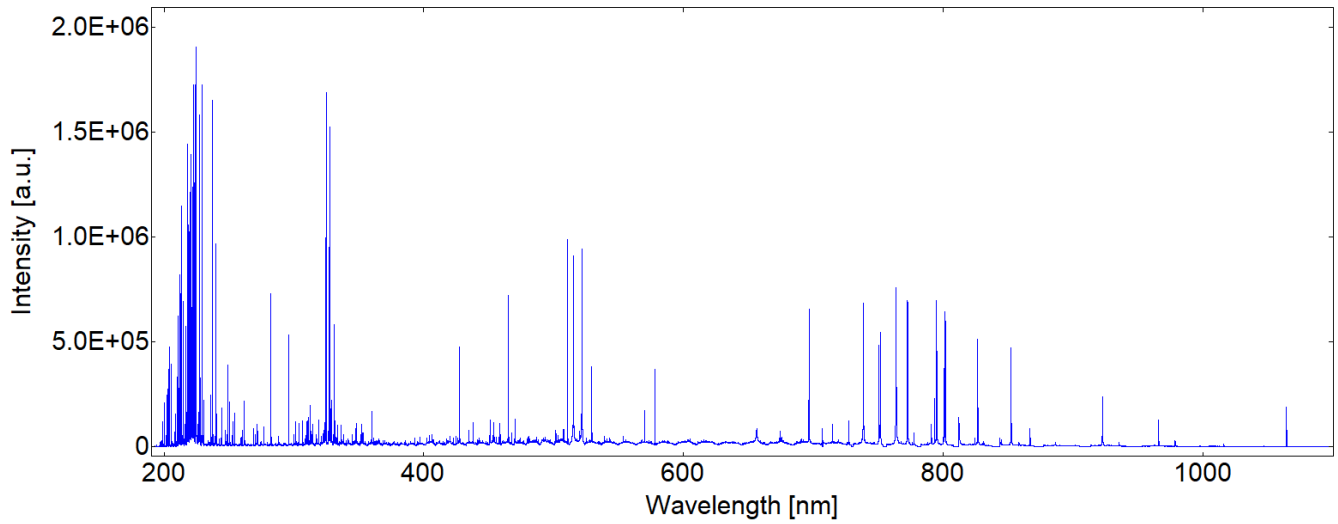
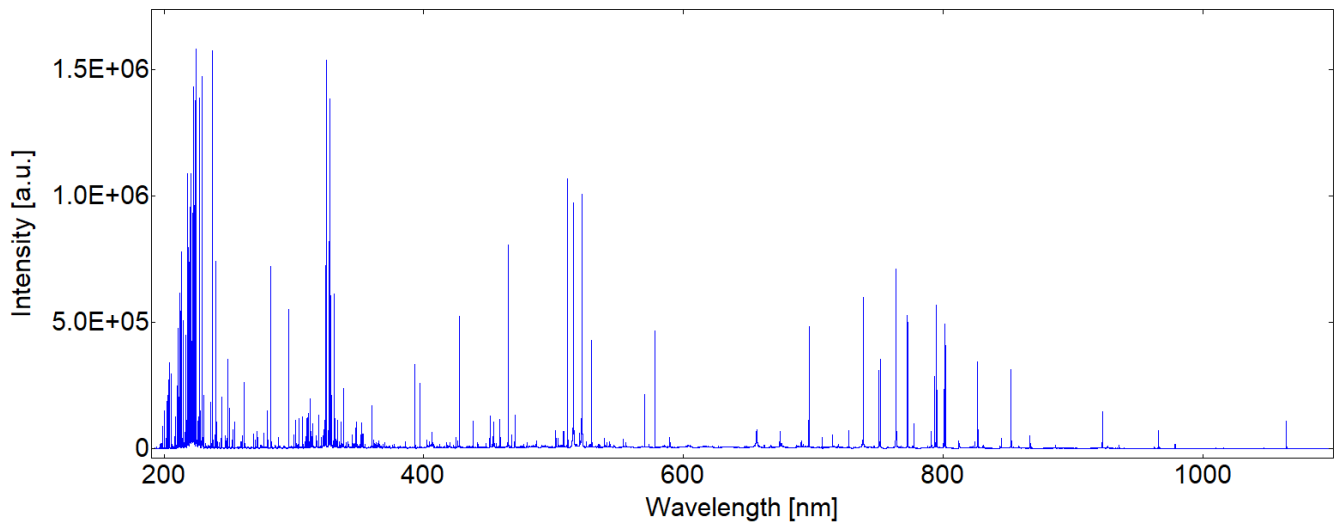
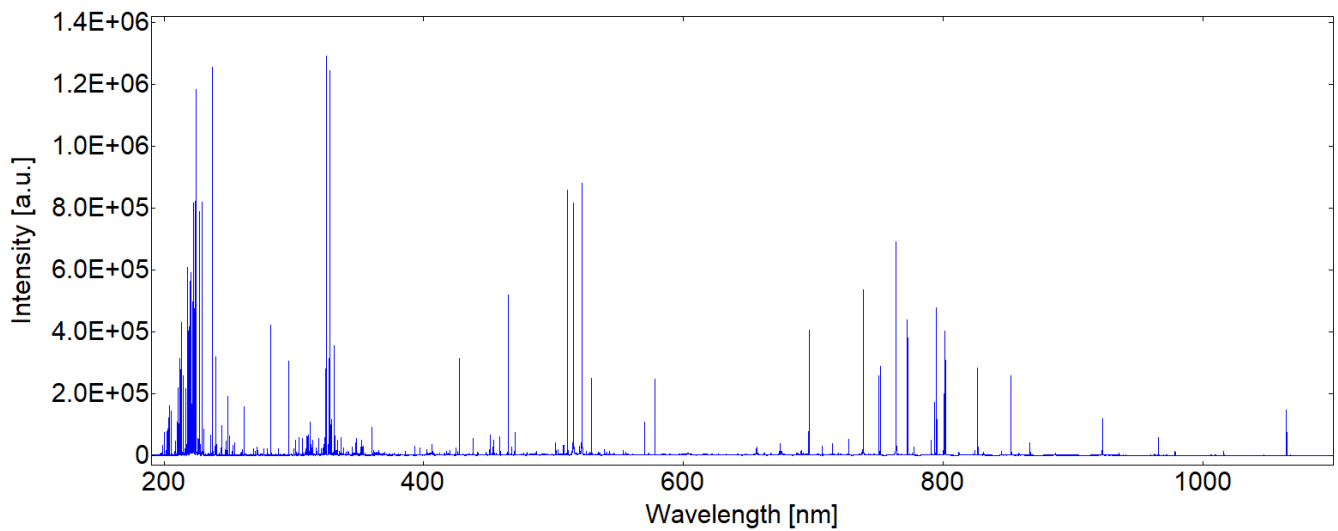
- Echelle dispersion cassette: UV3 ($\approx 26,600$ average resolving power), Slit size: $9 \times 30 \mu\text{m}$, Aperture Stop: 16 mm
- EMCCD Gain = 2800
- Wavelength step = 0.004 nm
- Wavelength range 190-1100 nm
- Integration time = 100 μs
- Integration delay = as stated in each spectrum
- Laser energy at the sample= approx. 50 mJ (unless otherwise stated, only one laser was fired while the other one remained off)
- Accumulation/Acquisition shots = 25
- Conditioning / Cleaning shots = 25
- Purge gas: Air or Argon (stated in each spectrum)

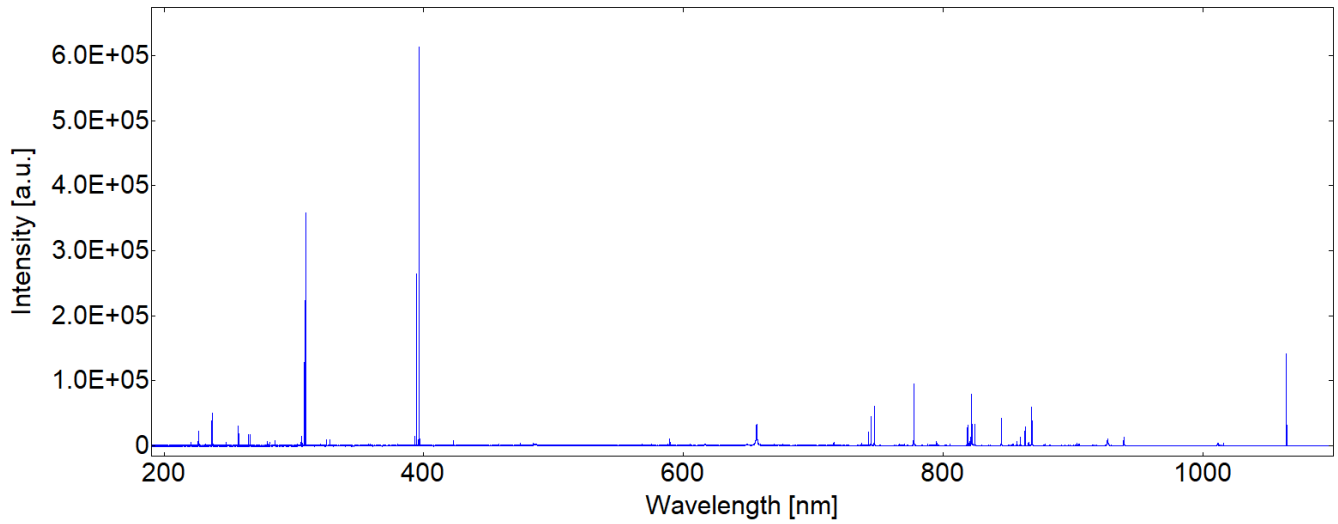
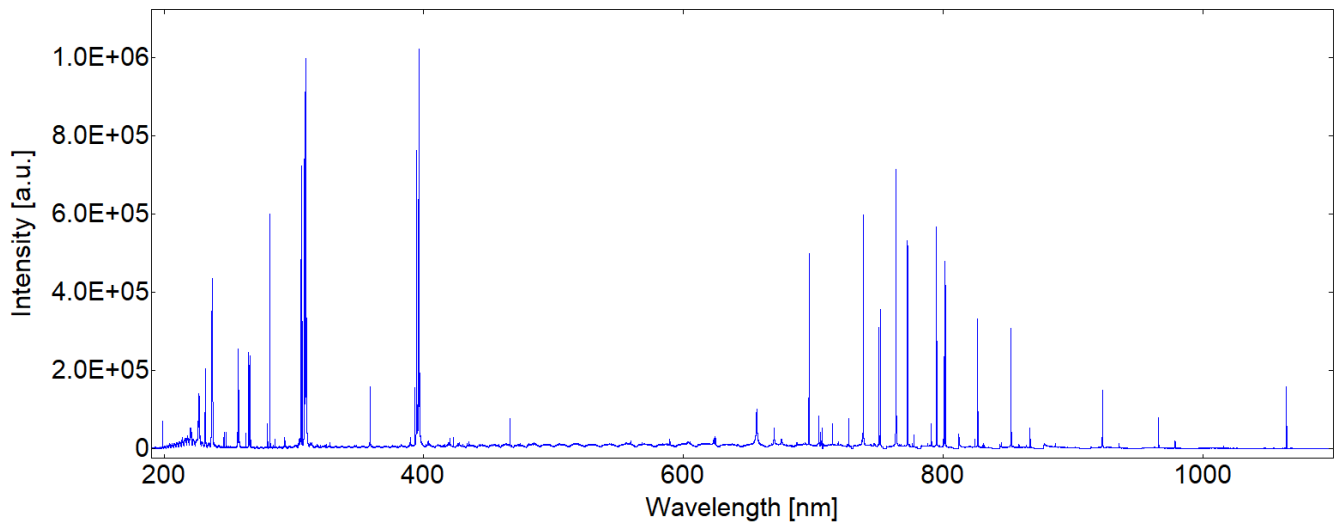
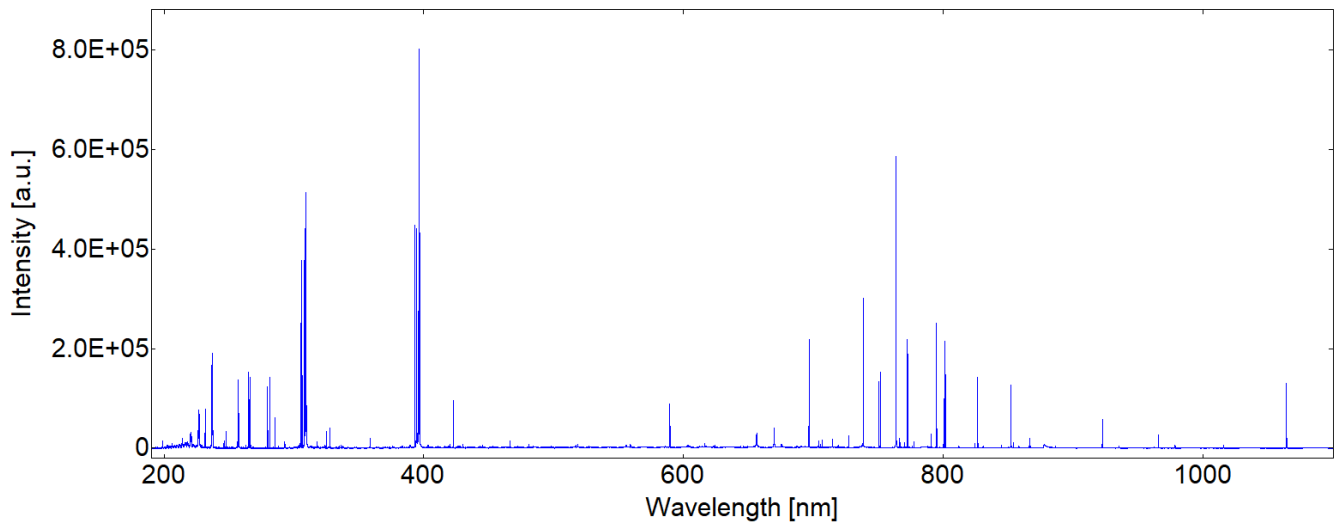
High purity copper (Air) 1 μs integration delay



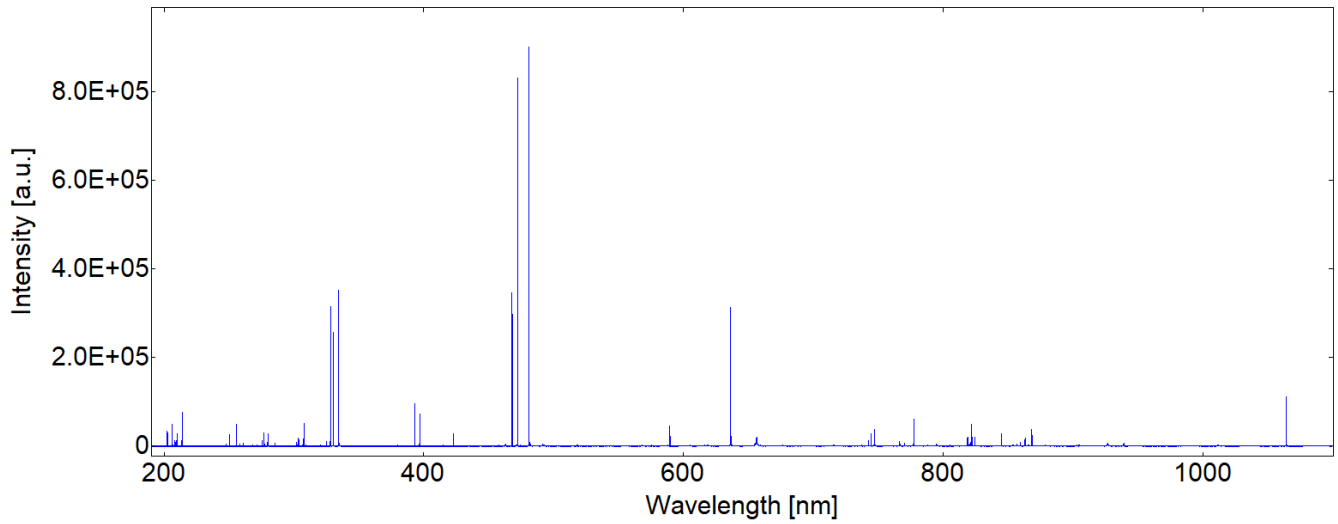
High purity copper (Air) 3 μs integration delay



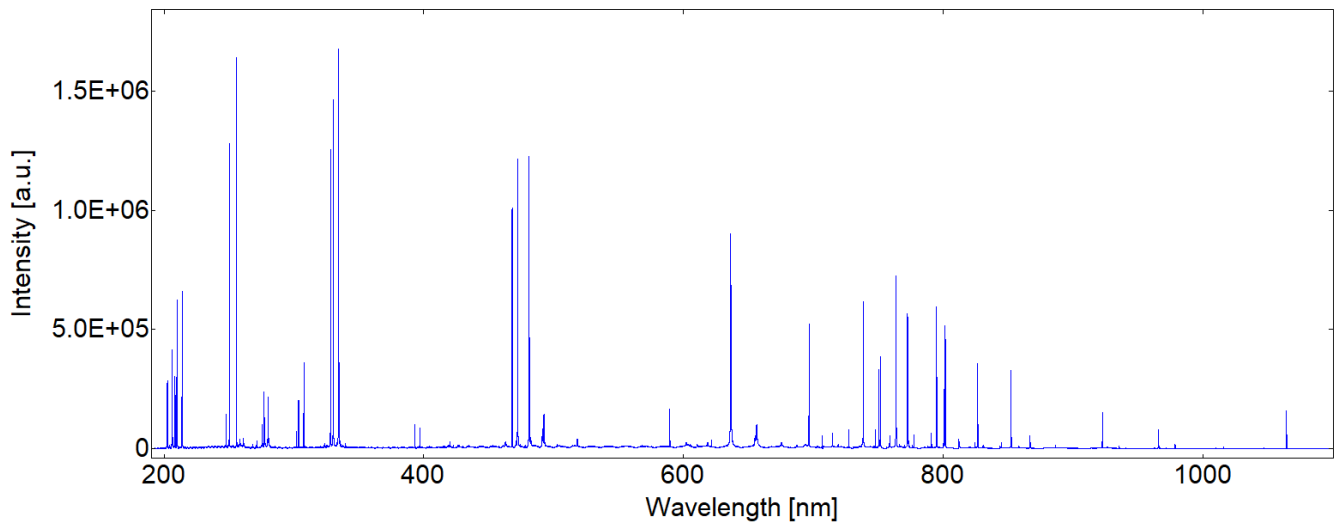
High purity copper (Argon) 1 μ s integration delay**High purity copper (Argon) 3 μ s integration delay****High purity copper (Argon) 10 μ s integration delay**

High purity aluminium (Air) 3 μ s integration delay**High purity aluminium (Argon) 3 μ s integration delay****High purity aluminium (Argon) 10 μ s integration delay**

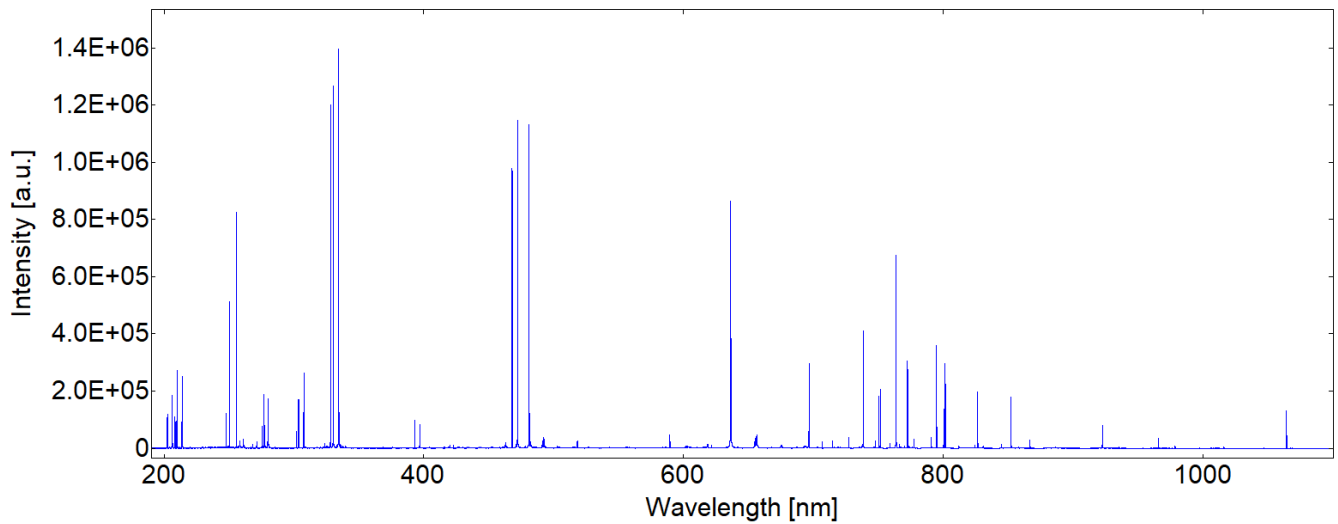
High purity zinc (Air) 3 μ s integration delay

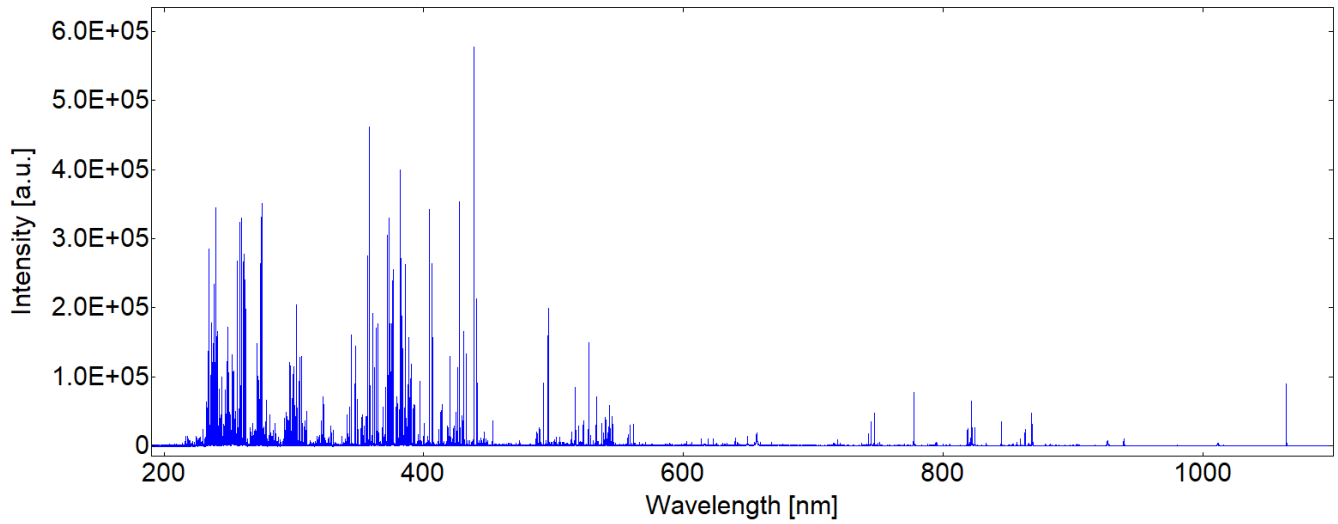
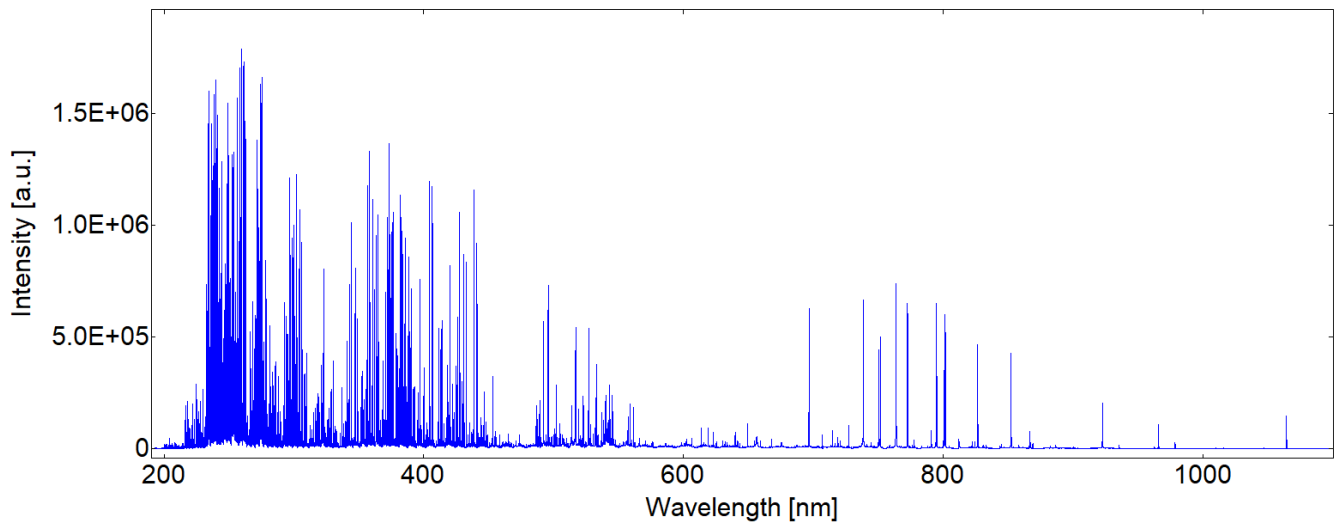
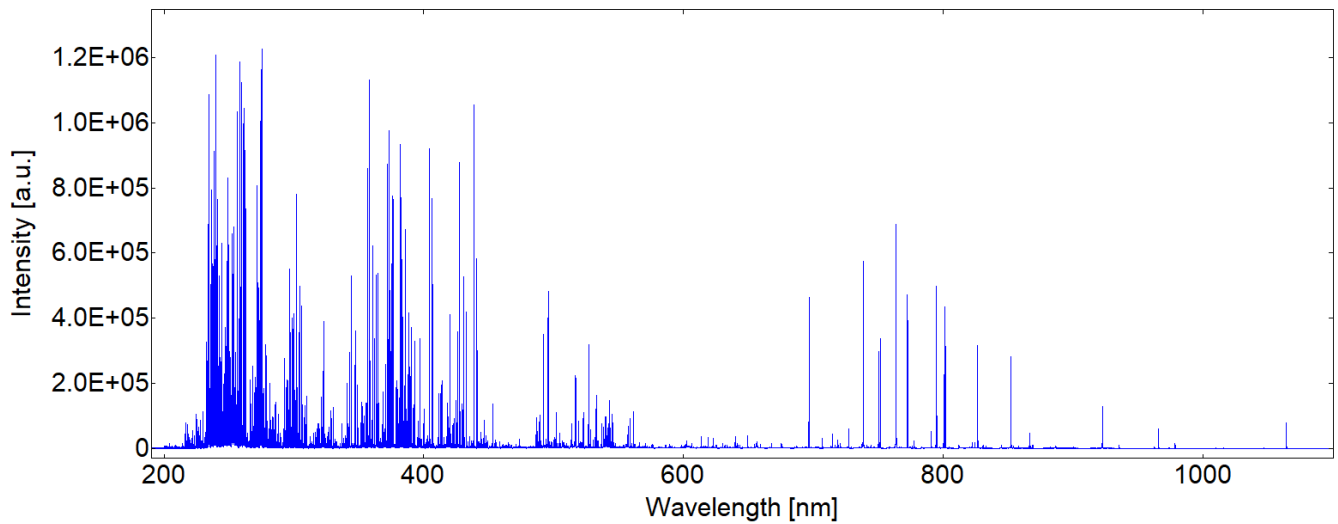


High purity zinc (Argon) 3 μ s integration delay

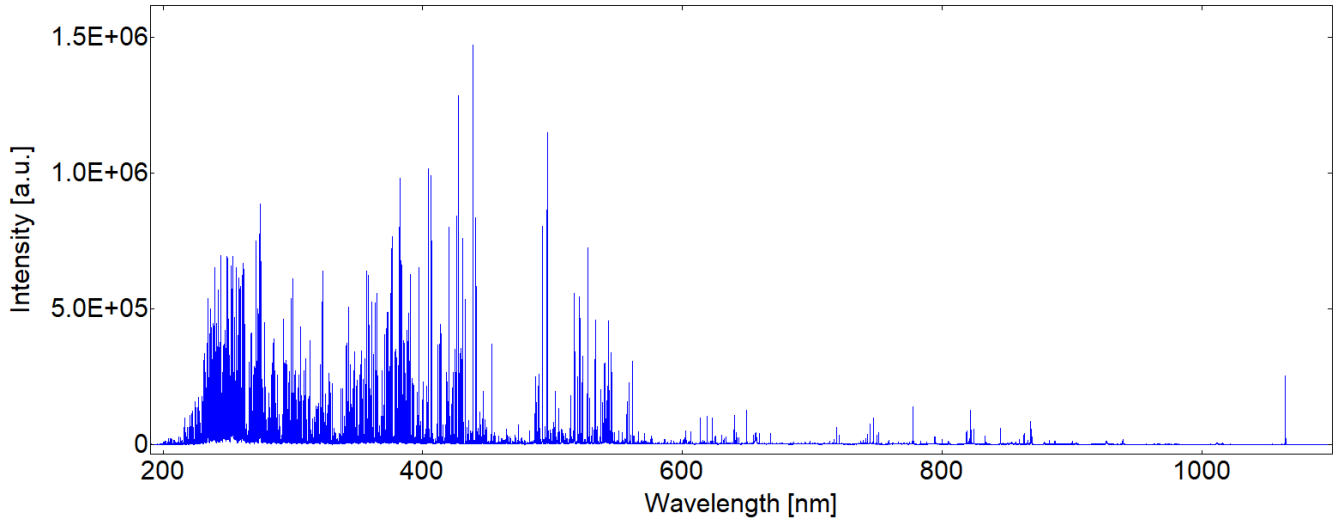


High purity zinc (Argon) 10 μ s integration delay

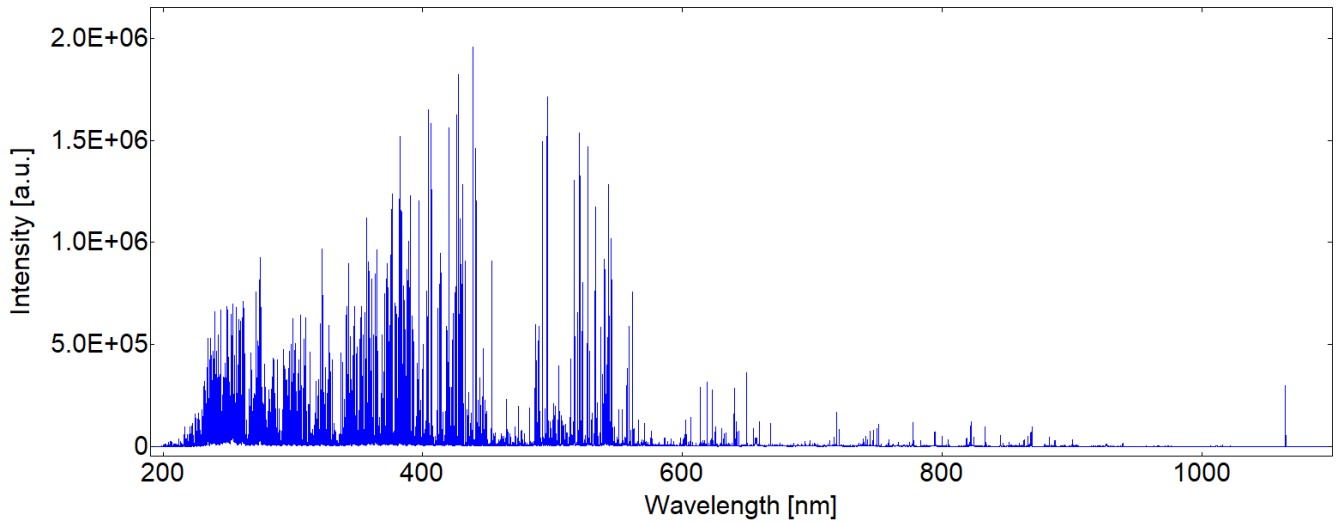


High purity iron (Air) 3 μ s integration delay**High purity iron (Argon) 3 μ s integration delay****High purity iron (Argon) 10 μ s integration delay**

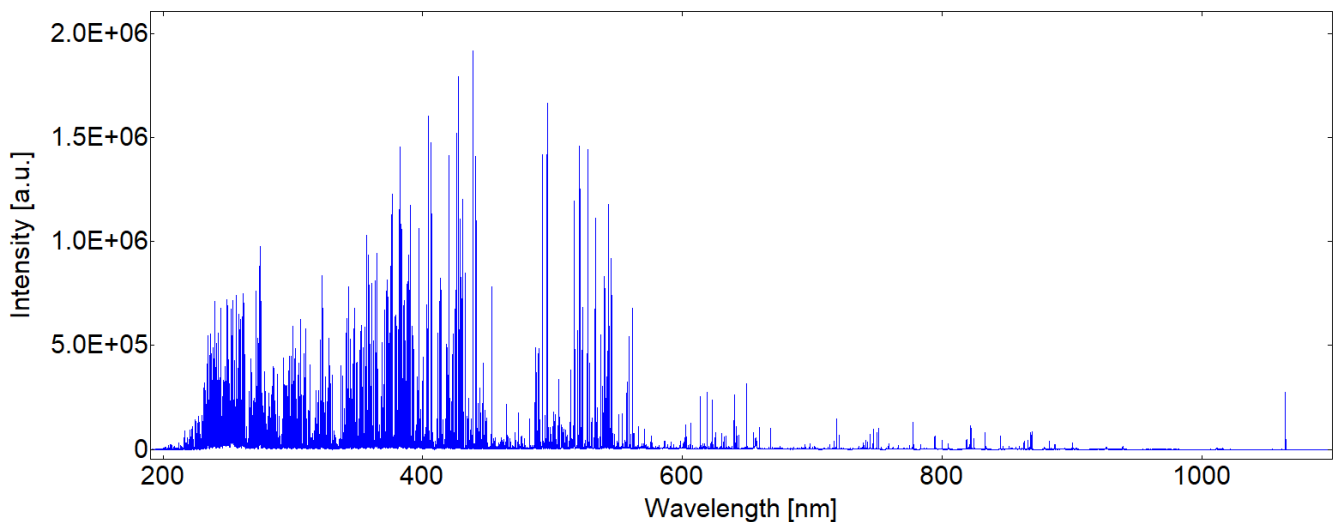
**Double pulse spectrum, Interpulse Delay= 0 μ s (Laser1 Energy= 50 mJ, Laser2 Energy 50mJ)
Low alloy steel sample (Air) 3 μ s integration delay (Q-Switch sync signal from Laser2 was used as trigger)**



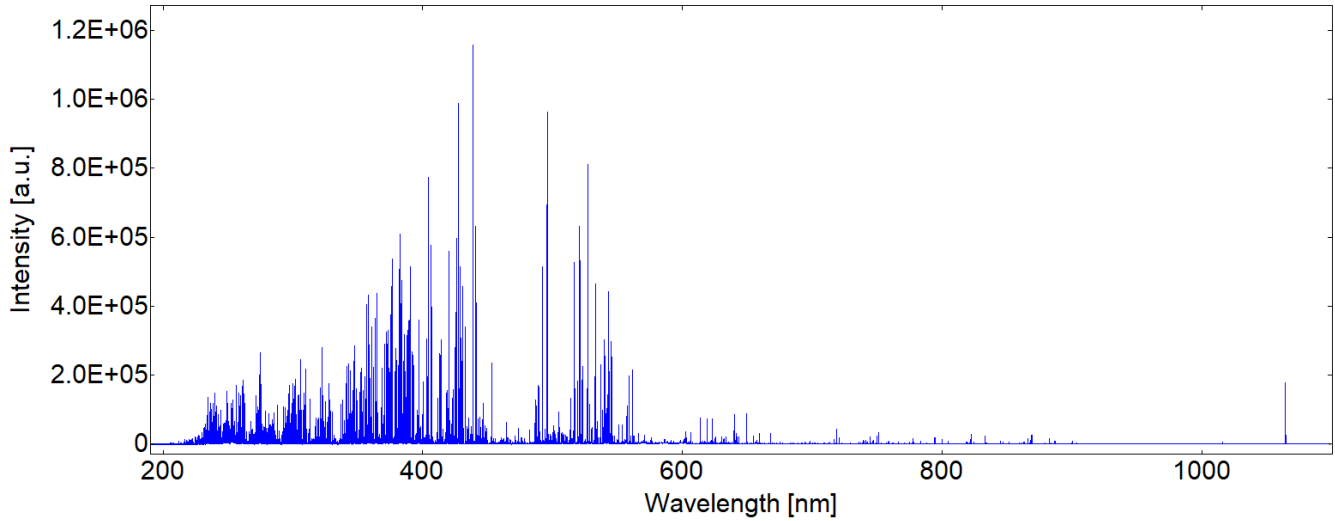
**Double pulse spectrum, Interpulse Delay= 1 μ s (Laser1 Energy= 50 mJ, Laser2 Energy 50mJ)
Low alloy steel sample (Air) 3 μ s integration delay (Q-Switch sync signal from Laser2 was used as trigger)**



**Double pulse spectrum, Interpulse Delay= 5 μ s (Laser1 Energy= 50 mJ, Laser2 Energy 50mJ)
Low alloy steel sample (Air) 3 μ s integration delay (Q-Switch sync signal from Laser2 was used as trigger)**



**Double pulse spectrum, Interpulse Delay= 50 μ s (Laser1 Energy= 50 mJ, Laser2 Energy 50mJ)
Low alloy steel sample (Air) 3 μ s integration delay (Q-Switch sync signal from Laser2 was used as trigger)**

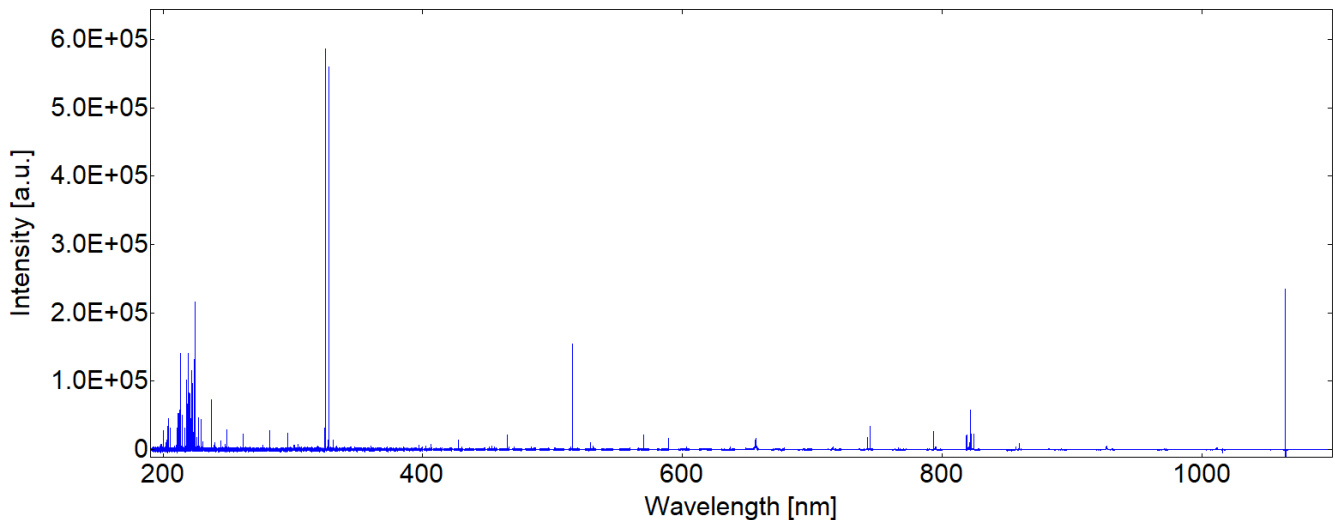


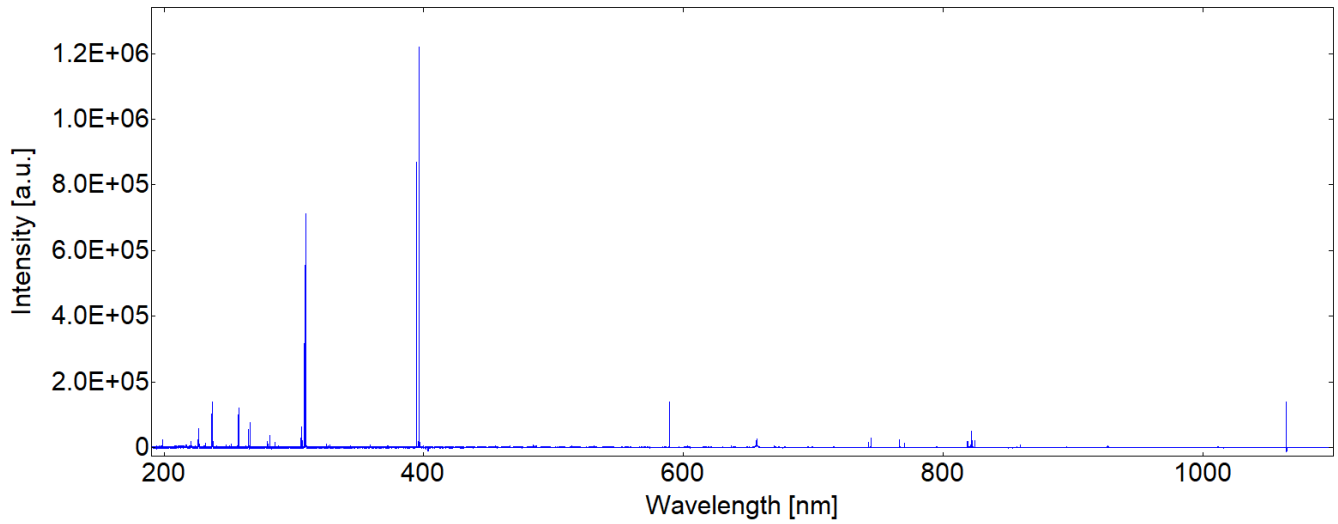
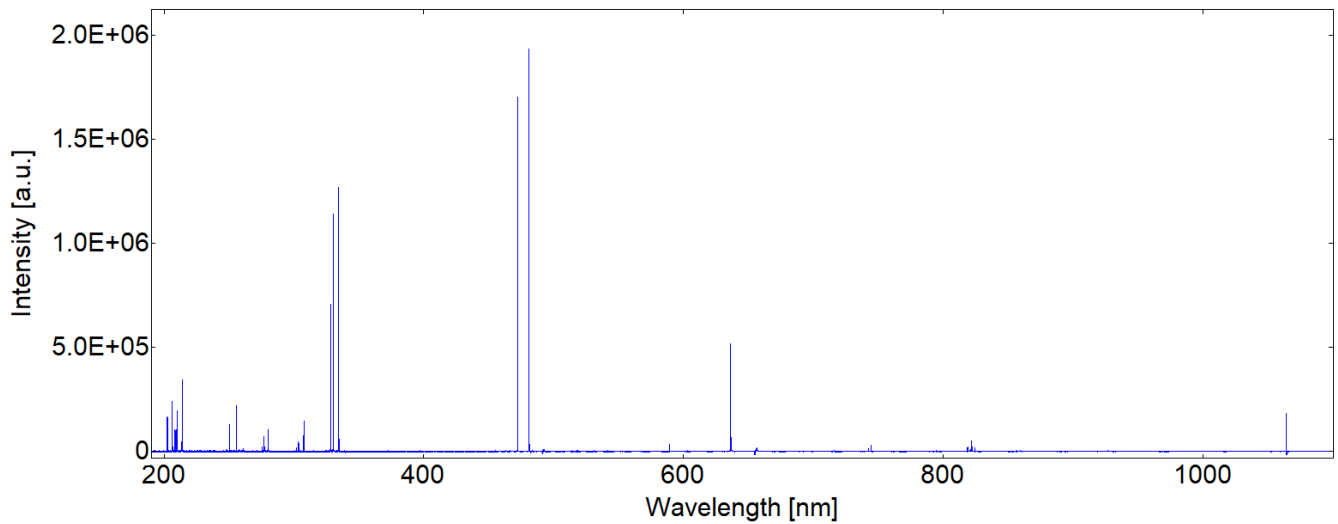
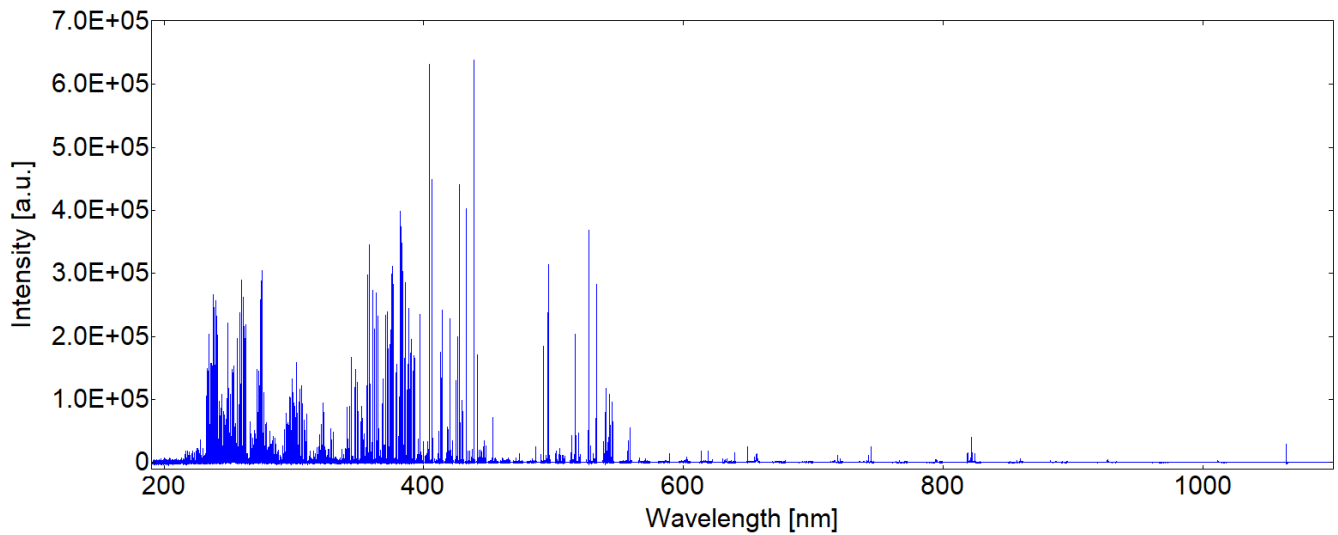
Test spectra 1064 nm configuration (IX1 Echelle dispersion cassette)

The spectra were acquired using the following parameters:

- Echelle dispersion cassette: IX1 ($\approx$ 44,200 average resolving power), Slit size: 10 x 30 μ m, Aperture Stop: 16 mm
- EMCCD Gain = 2800
- Wavelength step = 0.004 nm
- Wavelength range 190-1100 nm
- Integration time = 100 μ s
- Integration delay = 3 μ s
- Laser energy at the sample= approx. 50 mJ (only one laser was fired while the other one remained off)
- Accumulation/Acquisition shots = 25
- Conditioning / Cleaning shots = 25
- Purge gas: Air

High purity copper (Air) 3 μ s integration delay

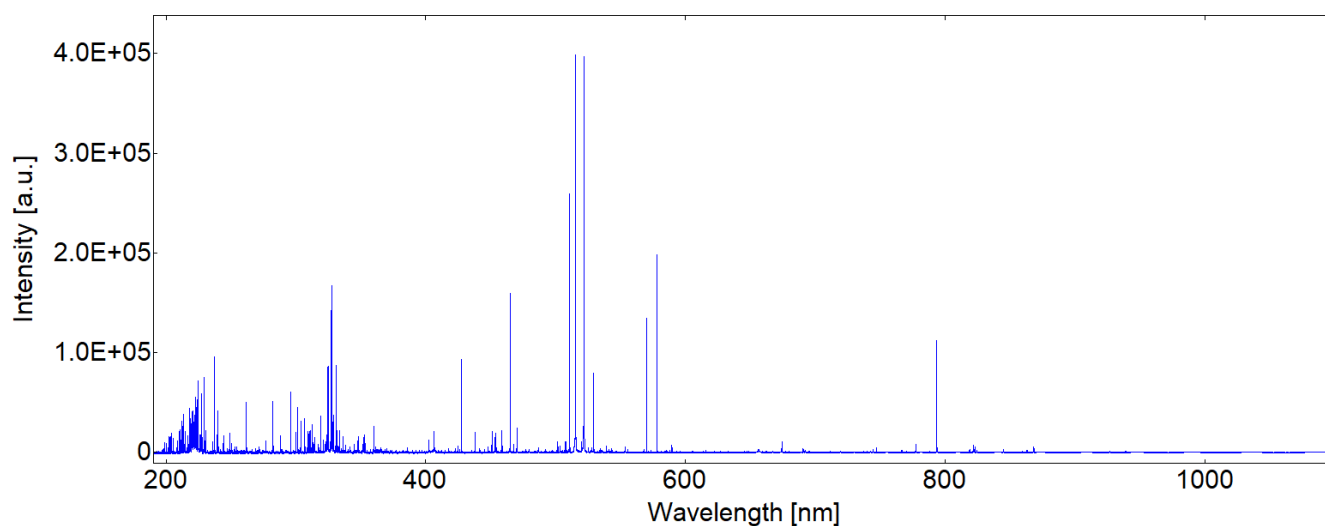
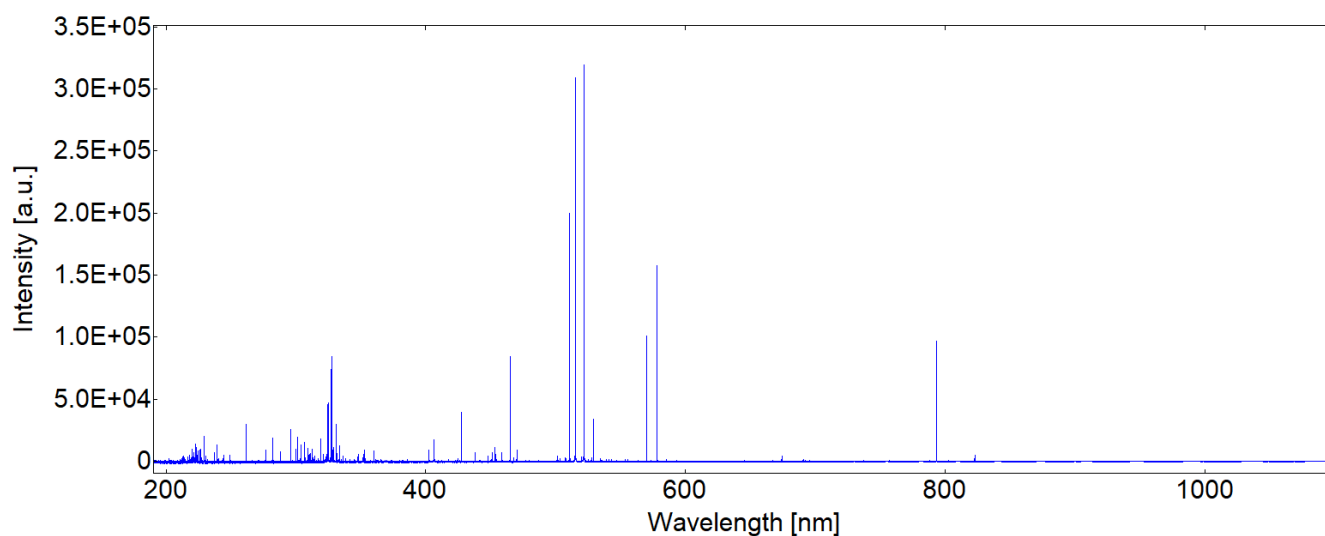


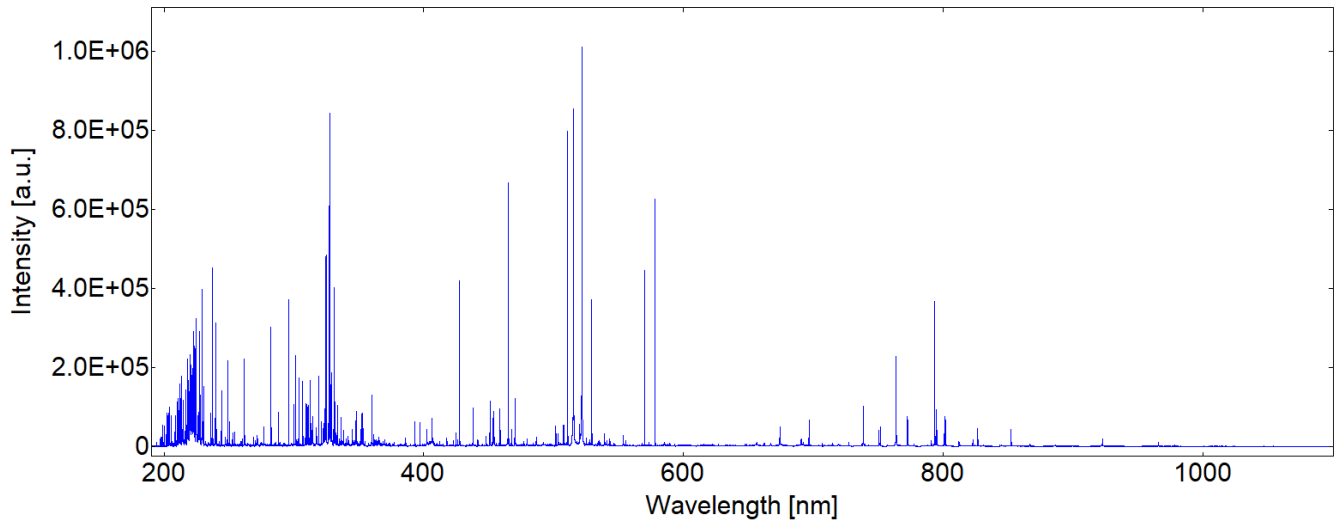
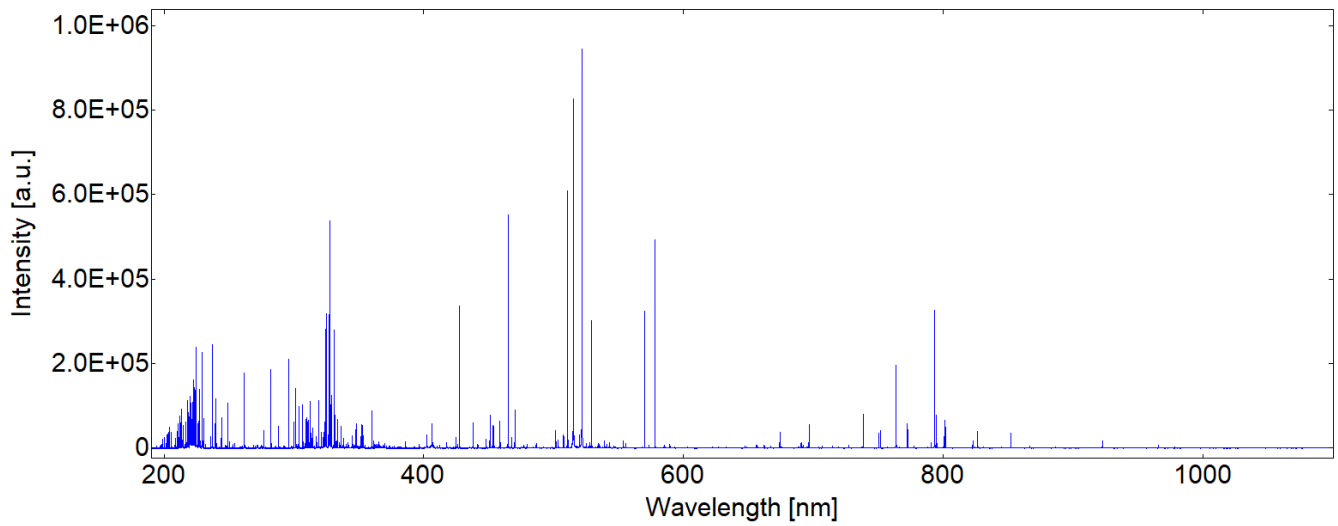
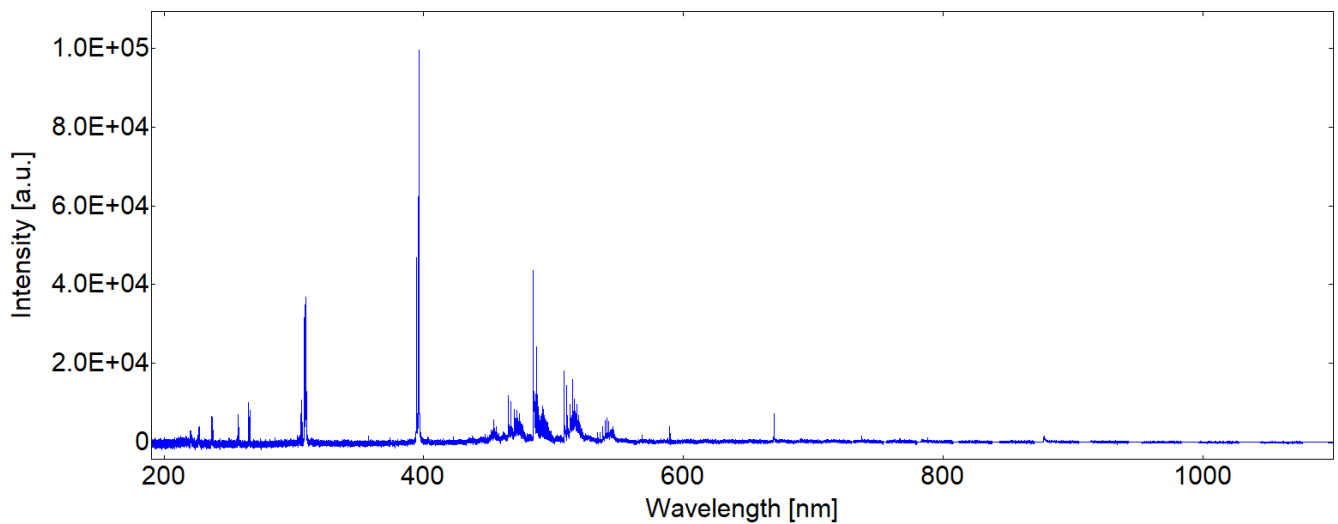
High purity aluminium (Air) 3 μ s integration delay**High purity zinc (Air) 3 μ s integration delay****High purity iron (Air) 3 μ s integration delay**

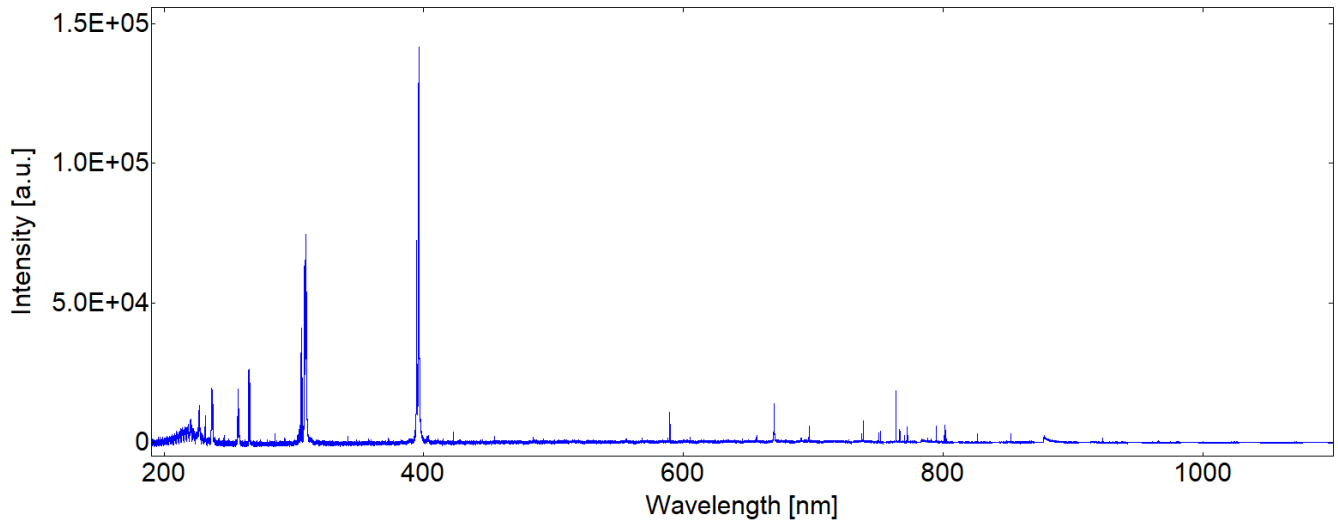
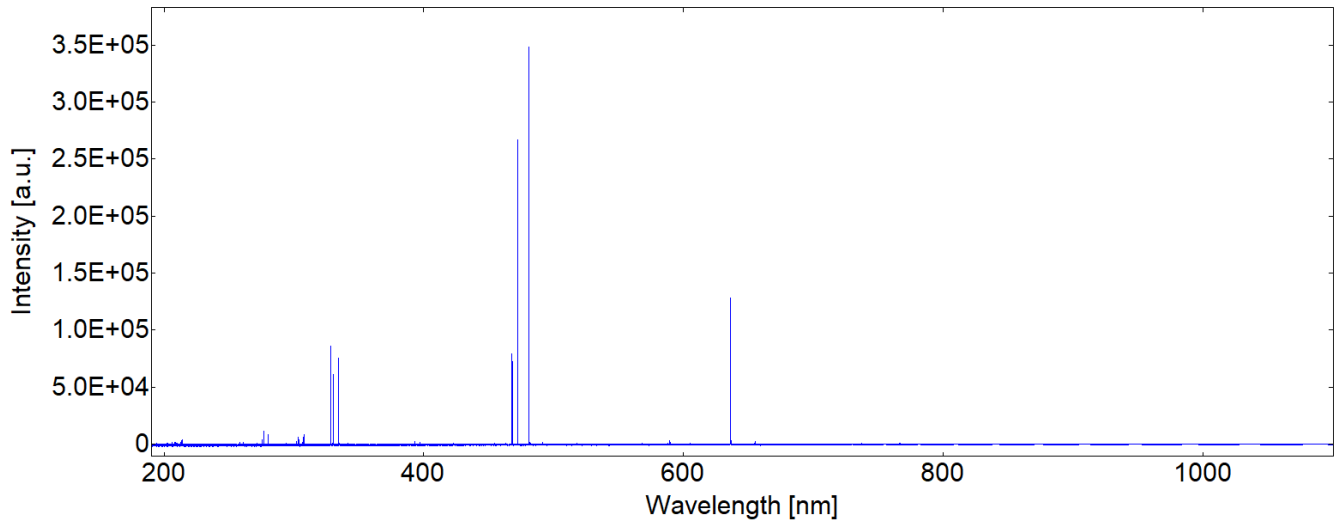
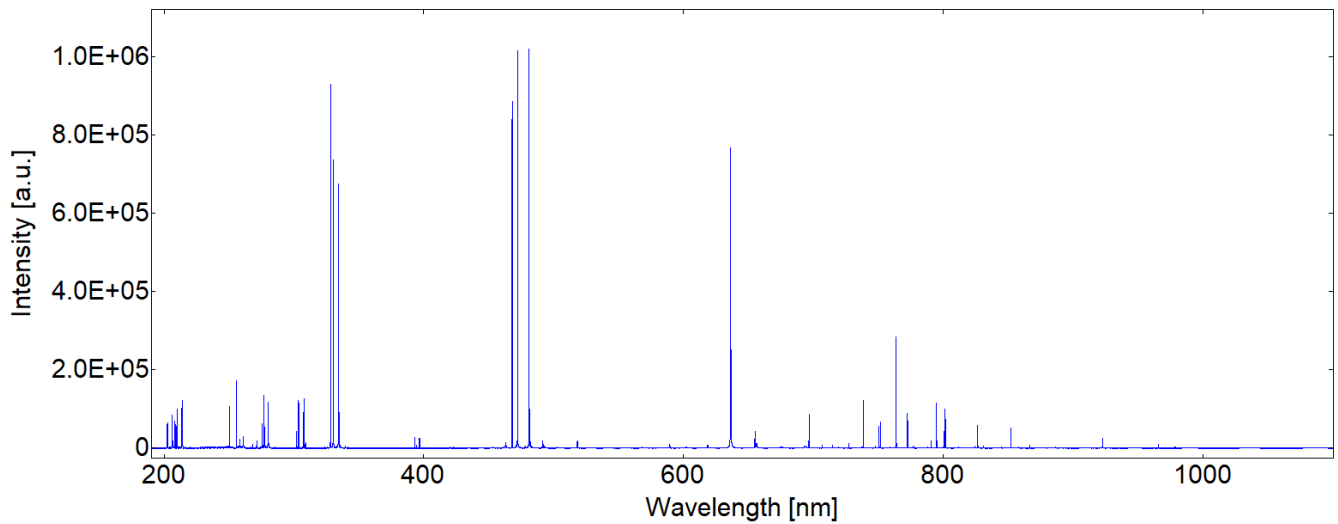
Test spectra 266 nm configuration (UV3 Echelle dispersion cassette)

The spectra were acquired using the following parameters:

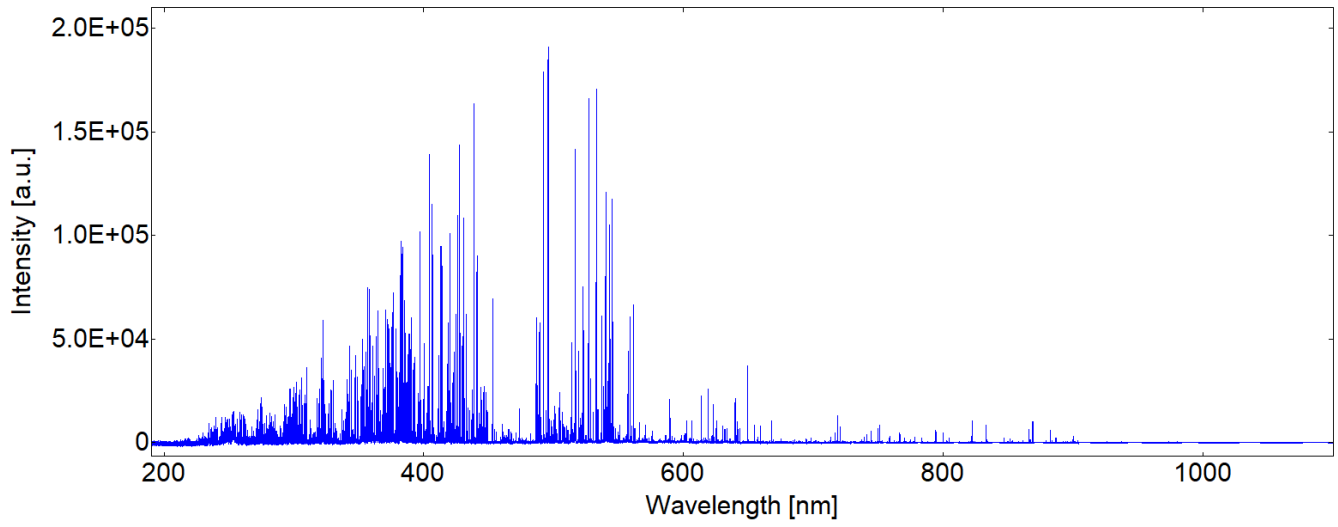
- Echelle dispersion cassette: UV3 ($\approx 26,600$ average resolving power), Slit size: $9 \times 30 \mu\text{m}$, Aperture Stop: 16 mm
- EMCCD Gain = 2800
- Wavelength step = 0.004 nm
- Wavelength range 190-1100 nm
- Integration time = 100 μs
- Integration delay = 3 μs
- Laser energy at the sample= approx. 25 mJ (only one laser was fired while the other one remained off)
- Accumulation/Acquisition shots = 25
- Conditioning / Cleaning shots = 25
- Purge gas: Air or Argon (stated in each spectrum)

High purity copper (Air) 1 μs integration delay**High purity copper (Air) 3 μs integration delay**

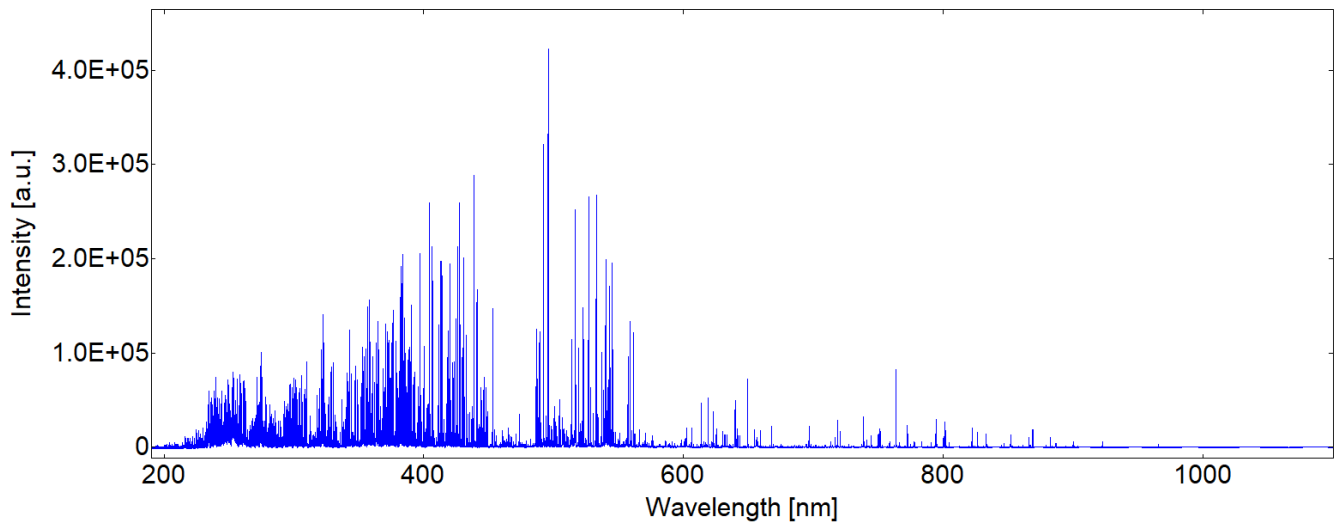
High purity copper (Argon) 1 μ s integration delay**High purity copper (Argon) 3 μ s integration delay****High purity aluminium (Air) 3 μ s integration delay**

High purity aluminium (Argon) 3 μ s integration delay**High purity zinc (Air) 3 μ s integration delay****High purity zinc (Argon) 3 μ s integration delay**

High purity iron (Air) 3 μ s integration delay

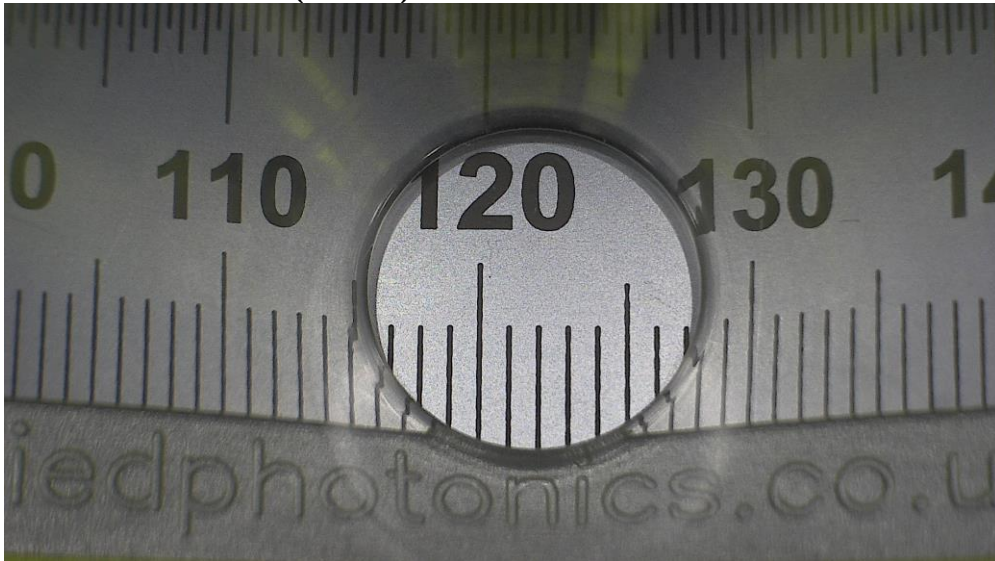


High purity iron (Argon) 3 μ s integration delay



Test of sample imaging cameras

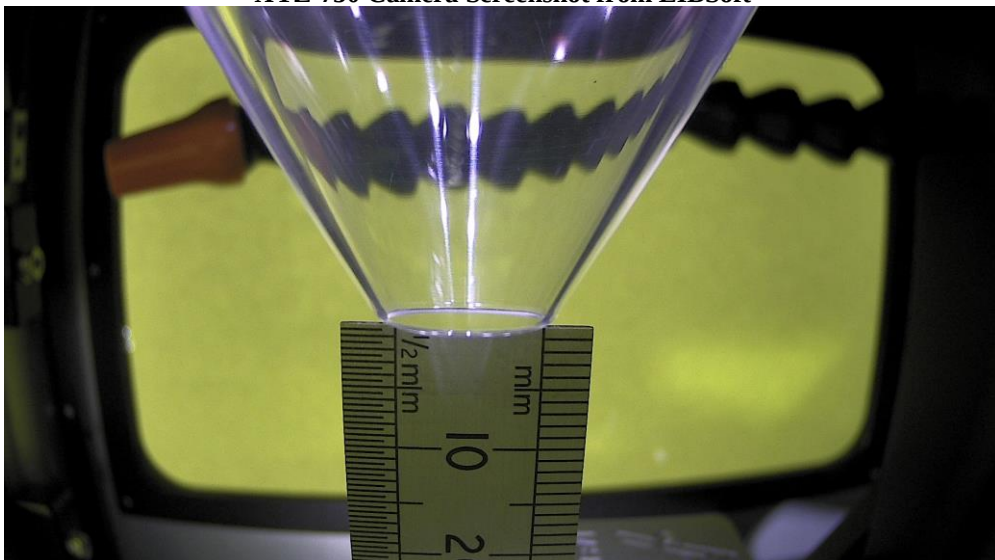
LIBS-6 (1064 nm) Camera Screenshot from LIBSoft



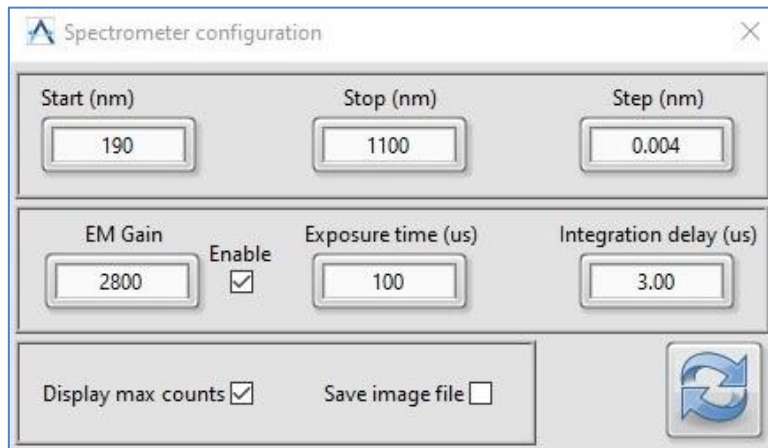
LIBS-6 (266 nm) Camera Screenshot from LIBSoft



XYZ-750 Camera Screenshot from LIBSoft



EMU configuration screen



A screenshot of a software window titled "Spectrometer configuration". The window contains several input fields and checkboxes for configuring a spectrometer. The fields are organized into three rows. The first row contains "Start (nm)" with a value of 190, "Stop (nm)" with a value of 1100, and "Step (nm)" with a value of 0.004. The second row contains "EM Gain" with a value of 2800, an "Enable" checkbox which is checked, "Exposure time (us)" with a value of 100, and "Integration delay (us)" with a value of 3.00. The third row contains "Display max counts" with a checked checkbox, "Save image file" with an unchecked checkbox, and a blue circular arrow icon.

Start (nm)	Stop (nm)	Step (nm)
190	1100	0.004

EM Gain	Enable	Exposure time (us)	Integration delay (us)
2800	☒	100	3.00

Display max counts	Save image file
☒	☐

End of Test Report